- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 780 - 2000nm T(AVG): < 1% FROM 565 - 715nm T(ABS): = 50% @ 750nm

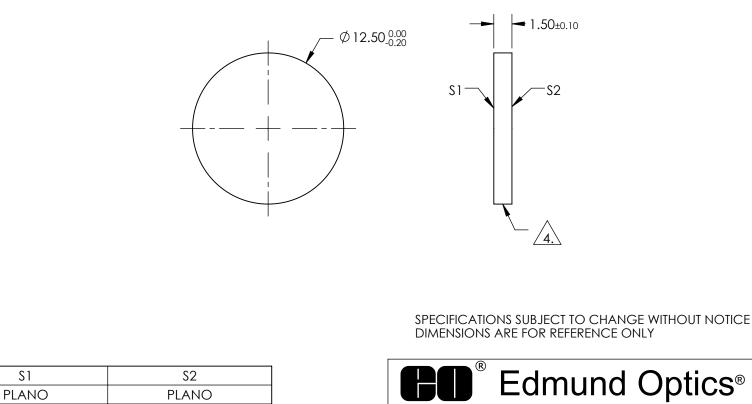
S1: MULTILAYER DIELECTRIC COATING S2: SINGLE LAYER MgF2

- 4. FINE GRIND SURFACE
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ ¼ WAVE
- 6. ROHS COMPLIANT

LONGPASS FILTER

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SHAPE	PLANO	PLANO					5
SURFACE QUALITY	40-20	40-20			OD2, Ø12.5mm, 750nm LONGPASS FILTER		
CLEAR APERTURE	80%	80%		TITLE			
COATING APERTURE	Ø11.00	Ø11.00		· · · · · · · · · · · · · · · · · · ·			
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	49031	SHEET 1 OF 1

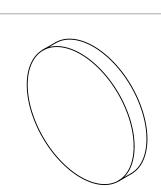
- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 830 - 2000nm T(AVG): < 1% FROM 600 - 760nm T(ABS): = 50% @ 800nm

S1: MULTILAYER DIELECTRIC COATING S2: SINGLE LAYER MgF2

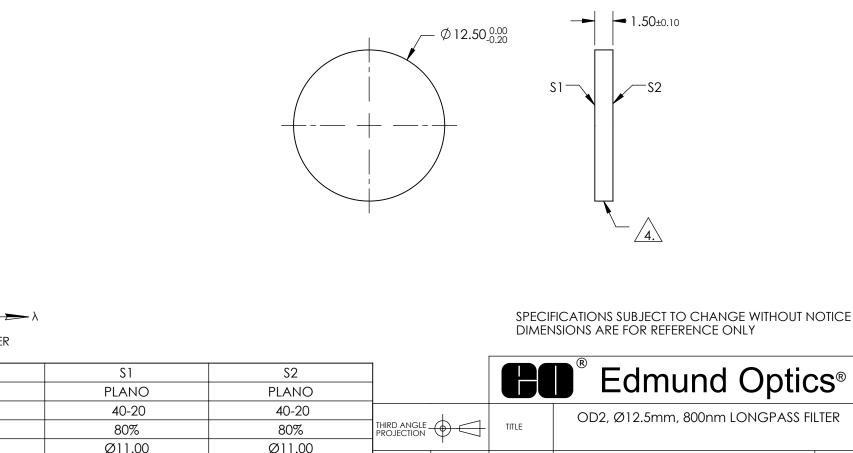


- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



SHEET

1 OF 1



ALL DIMS IN

PROTECTIVE AS NEEDED | PROTECTIVE AS NEEDED

mm

DWG NO

49032

FOR INFORMATION ONLY:

PARTS TO THIS DRAWING

ANUFACTURE

## LONGPASS FILTER

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SHAPE

BEVEL

SURFACE QUALITY

CLEAR APERTURE

COATING APERTURE

- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 880 - 2000nm T(AVG): < 1% FROM 635 - 805nm T(ABS): = 50% @ 850nm

S1: MULTILAYER DIELECTRIC COATING S2: SINGLE LAYER MgF2



- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ ¼ WAVE
- 6. ROHS COMPLIANT

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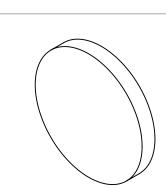
SHAPE

BEVEL

SURFACE QUALITY

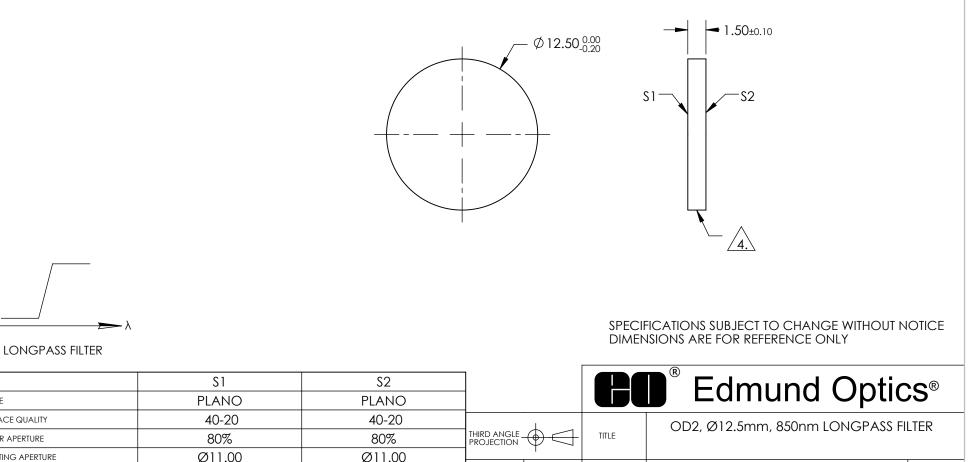
CLEAR APERTURE

COATING APERTURE



SHEET

1 OF 1



ALL DIMS IN

PROTECTIVE AS NEEDED | PROTECTIVE AS NEEDED

mm

DWG NO

49033

FOR INFORMATION ONLY:

PARTS TO THIS DRAWING

ANUFACTURE

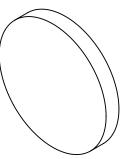
- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

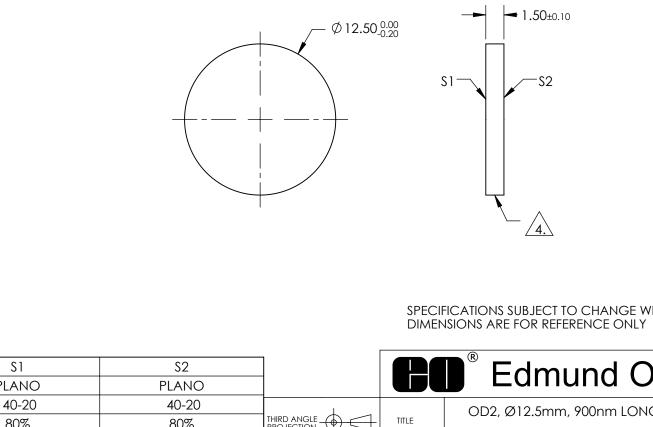
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 935 - 2000nm T(AVG): < 1% FROM 675 - 855nm T(ABS): = 50% @ 900nm

S1: MULTILAYER DIELECTRIC COATING S2: SINGLE LAYER MgF2

- 4. FINE GRIND SURFACE
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT







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SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE

	S1	\$2				Edmund Optic	۲C®
SHAPE	PLANO	PLANO					5
SURFACE QUALITY	40-20	40-20				OD2, Ø12.5mm, 900nm LONGPASS FI	ITER
CLEAR APERTURE	80%	80%	THIRD ANGLE	$\rightarrow \bigcirc$	TITLE		
COATING APERTURE	Ø11.00	Ø11.00					
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	49034	SHEET 1 OF 1

- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

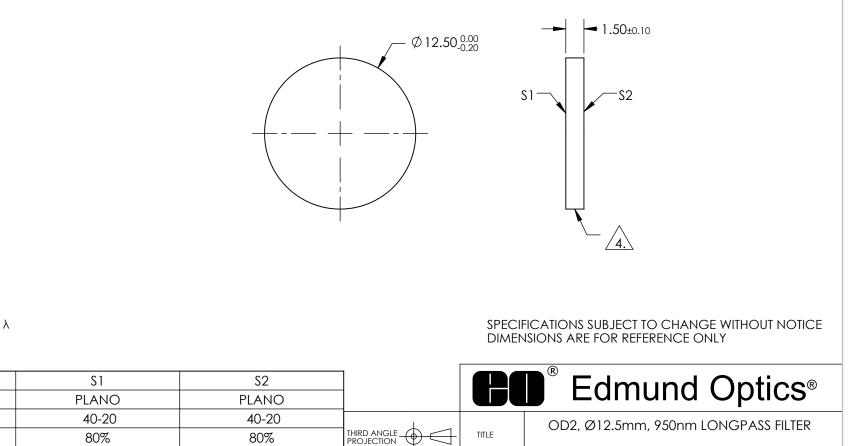
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 985 - 2000nm T(AVG): < 1% FROM 715 - 900nm T(ABS): = 50% @ 950nm

S1: MULTILAYER DIELECTRIC COATING S2: SINGLE LAYER MgF2



- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT





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#### LONGPASS FILTER

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	S1	S2				<sup>©</sup> Edmund Optic	<b>C</b> ®
SHAPE	PLANO	PLANO					5
SURFACE QUALITY	40-20	40-20		1		OD2, Ø12.5mm, 950nm LONGPASS FI	ITER
CLEAR APERTURE	80%	80%	THIRD ANGLE _ PROJECTION	$\bigcirc \bigcirc \bigcirc$	TITLE		
COATING APERTURE	Ø11.00	Ø11.00		ļ			
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	49035	SHEET 1 OF 1

- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 1035 - 2000nm T(AVG): < 1% FROM 750 - 950nm T(ABS): = 50% @ 1000nm

S1: MULTILAYER DIELECTRIC COATING S2: SINGLE LAYER MgF2



5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE

Ø11.00

PROTECTIVE AS NEEDED | PROTECTIVE AS NEEDED

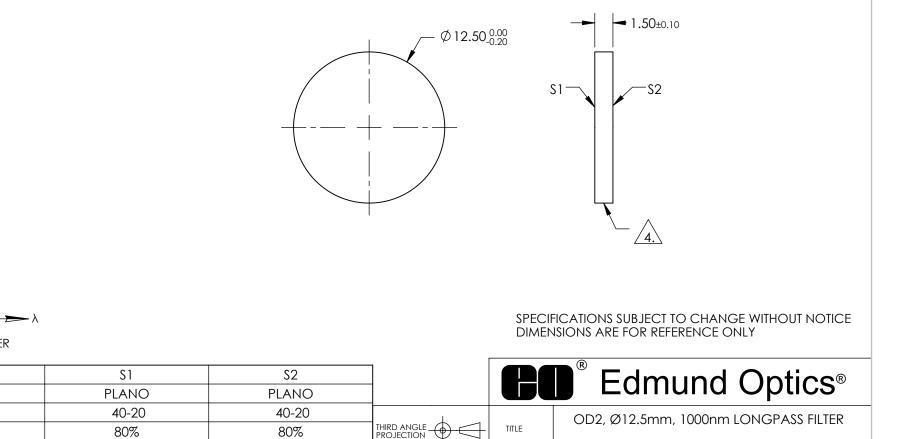
Ø11.00

6. ROHS COMPLIANT



SHEET

1 OF 1



ALL DIMS IN

mm

DWG NO

49036

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### LONGPASS FILTER

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SHAPE

BEVEL

SURFACE QUALITY

CLEAR APERTURE

COATING APERTURE

- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 1085 - 2000nm T(AVG): < 1% FROM 790 - 1000nm T(ABS): = 50% @ 1050nm

S1: MULTILAYER DIELECTRIC COATING S2: SINGLE LAYER MgF2



5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ ¼ WAVE

Ø11.00

PROTECTIVE AS NEEDED | PROTECTIVE AS NEEDED

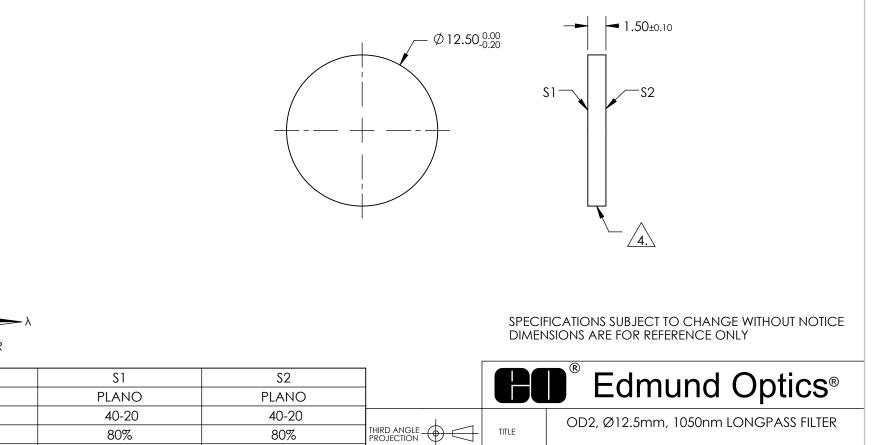
Ø11.00

6. ROHS COMPLIANT



SHEET

1 OF 1



mm

DWG NO

49037

ALL DIMS IN

### LONGPASS FILTER

Т

SHAPE

BEVEL

SURFACE QUALITY

CLEAR APERTURE

COATING APERTURE

- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 1135 - 2000nm T(AVG): < 1% FROM 825 - 1045nm T(ABS): = 50% @ 1100nm

S1: MULTILAYER DIELECTRIC COATING S2: SINGLE LAYER MgF2



- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ ¼ WAVE
- 6. ROHS COMPLIANT

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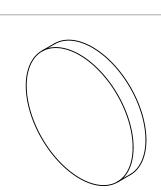
SHAPE

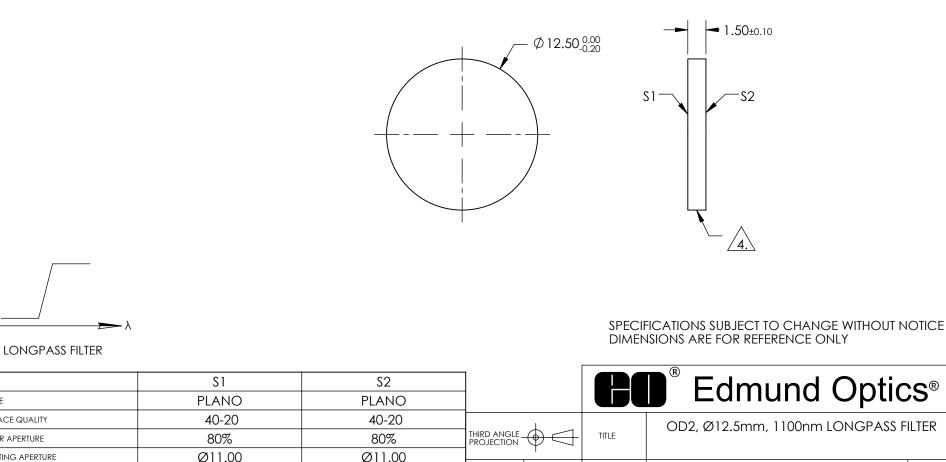
BEVEL

SURFACE QUALITY

CLEAR APERTURE

COATING APERTURE





ALL DIMS IN

PROTECTIVE AS NEEDED | PROTECTIVE AS NEEDED

mm

DWG NO

49038

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PARTS TO THIS DRAWING

ANUFACTURE

SHEET 1 OF 1